









<b>FORM PTO-1449</b>  <b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b>  (Use several sheets if necessary)	Docket Number (Optional)	Application Number
	YOR920030312US1	Not yet assigned
	Applicant	
	David B. Mitzi	
	Filing Date	Group Art Unit
	Concurrently herewith	Not yet assigned



### U. S. PATENT DOCUMENTS


EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

### FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

### OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)

	J. Vanfleteren, "Polycrystalline CdSe Films for Thin Film Transistors", Journal of Crystal Growth 86 (1988) 924-928. ✓
	Chern et al., "Spin-Coated Amorphous Chalcogenide Films", J. Appl. Phys. 53 (10), October 1982 ✓

EXAMINER 	DATE CONSIDERED 11/15/04
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with PEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.